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APPLICANTS

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** CONTINUING DATA ***** *BK, YES*

This application is a DIV of 09/352,198 07/13/1999 ABN

** FOREIGN APPLICATIONS *****

JAPAN 10-203205 07/17/1998 *BK, YES*

JAPAN 11-135055 05/14/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

07/26/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS <i>18</i> <i>46</i>	INDEPENDENT CLAIMS <i>12</i> <i>16</i>
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Brown Kibede</i> Examiner's Signature <i>BK</i> Initials				

ADDRESS

31780

TITLE

Crystalline semiconductor thin film, method of fabricating the same, semiconductor device and method of fabricating the same

FILING FEE RECEIVED 3612	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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